

Form PTO-1449 (modified)		Atty. Docket No. 102-0075US-3	Serial No. unknown 10 762847
List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant Cem Basceri; Gurtej S. Sandhu	
		Filing Date: August 29, 2002	Group: unknown 1762
U.S. Patent Documents See Page Error! Bookmark not defined.	Foreign Patent Documents See Page 1	Other Art See Page 1	

U.S. Patent Documents

Exam Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	4966646	10/30/1990	Zdeblick			
	A2	5865417	02/02/1999	Harris et al.			
	A3	6062256	05/16/2000	Miller et al.			
	A4	6123107	09/26/2000	Selser et al.			
	A5	6129331	10/10/2000	Henning et al.			
	A6	6149123	11/21/2000	Harris et al.			
	A7	6160243	12/12/2000	Cozad			
	A8	6182603	02/06/2001	Shang et al.			
	A9	6210754	04/03/2001	Lu et al.			
	A10	6237394	05/29/2001	Harris et al.			
	A11	6290491	09/18/2001	Shahvandi et al.			
	A12	09/651037		Mardian			08/30/2000
	A13						
	A14			NOT A PUBLICATION			
	A15			PUBLIC			
	A16						
	A17						
	A18						
	A19						
	A20						

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Foreign Patent Documents

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	B1						
	B2						
	B3						
	B4						
	B5						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	A.K. Henning et al, "Microfluidic MEMS for Semiconductor Processing," IEEE Transactions on Components, Packaging, and Manufacturing Technology B21, pp. 329-37 (1998)
	C2	A.K. Henning, "Microfluidic MEMS," Proceedings: IEEE Aerospace Conference, Paper 4.906 (IEEE Press, Piscataway, NJ, 1998)
	C3	J.S. Fitch et al., "Pressure-Based Mass-Flow Control Using Thermopneumatically-Actuated Microvalves," Proceedings: Solid-State Sensor and Actuator Workshop, pp. 162-65 (Transducers Research Foundation, Cleveland, OH, 1998)
	C4	A.K. Henning et al., "Contamination Reduction Using MEMS-Based, High-Precision Mass Flow Controllers," Proceedings: SEMICON West Symposium on Contamination Free Manufacturing for Semiconductor Processing (SEMI, Mountain View, CA, 1998)
	C5	A.K. Henning, "Liquid and Gas-Liquid Phase Behavior in Thermopneumatically Actuated Microvalves," Proceedings: Micro Fluidic Devices and Systems, Vol. 3515, pp. 53-63 (International Society for Optical Engineering, Bellingham, WA, 1998)
	C6	A.K. Henning et al., "Performance of MEMS-Based Gas Distribution and Control Systems for Semiconductor Processing," Proceedings: Micromachined Devices and Components, Vol. 3514, pp. 159-170 (International Society for Optical Engineering, Bellingham, WA, 1998)



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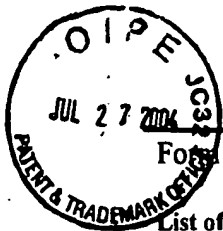
Exam. Init.	Ref. Des.	Citation
	C7	A.K. Henning et al, "Performance of MEMS-Based Gas Distribution and Control Systems for Semiconductor Processing," Proceedings: SEMICON West Workshop on Gas Distribution (SEMI, Mountain View, CA, 1998)
	C8	D. Maillefer et al., "A High-Performance Silicon Micropump for Disposable Drug Delivery Systems," Proceedings of the MEMS 2001 Conference, Interlaken Switzerland, pp. 413-17 (2001)
	C9	R. Bardell et al., "Designing High-Performance Micro-Pumps Based On No-Moving-Parts Valves," ASME— Microelectromechanical Systems (MEMS), DSC-Vol. 62 HTD-Vol. 354, pp. 47-53 (1997)
	C10	A. Olsson, "Valve-Less Diffuser Micropumps" (1998), published at http://www.s3.kth.se/mst/research/dissertations/pdf/andersodoc.pdf .
	C11	Redwood MicroSystems Introduces Semiconductor Grade Products, 07/12/00, published at www.redwoodmicro.com/semicon.html , pages 1 and 2.
	C12	P. Woias, "Micropumps—Summarizing the First Two Decades," Proceedings: SPIE— International Society for Optical Engineering, Vol. 4560, pp. 39-52 (2001)
	C13	A.K. Henning et al., "A Thermopneumatically Actuated Microvalve for Liquid Expansion and Proportional Control," Proceedings: Transducers '97: 1997 International Solid State Sensors and Actuators Conference, pp. 825-28 (IEEE Press, Piscataway, NJ, 1997)
	C14	U.S. Patent Application filed August 23, 2002, inventors Cem Basceri & Gurtej Sandhu, entitled "Reactors Having Gas Distributors and Methods for Depositing Materials Onto Micro-device Workpieces" (Micron Docket 01-1047; U.S. patent application serial number not yet assigned).

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INFORMATION DISCLOSURE STATEMENT

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Atty. Docket No.
102-0075US3Serial No.
10/762,847Applicant / Inventor
Micron Technology, Inc., / Cem Basceri et al.Filing Date:
1/22/2004Group:
unk 1762

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	6080446	6/27/2000	Tobe et al.	427	255.394	
	A2	6596085	7/22/2003	Schmitt et al.	118	726	2/1/2000
	A3	5380396	1/10/1995	Shikida et al	156	630	
	A4	6705345	3/16/2004	Bifano	137	597	11/8/2000
	A5	6432831	8/13/2002	Dhindsa	438	710	3/23/2001
	A6	6358323	3/19/2002	Schmitt et al.	118	726	6/21/1998
	A7	6302964	10/16/2001	Umotoy	118	715	3/16/2000
	A8	6287980	9/11/2001	Hanazaki et al.	438	726	10/12/1999
	A9	6245192	6/12/2001	Dhindsa et al.	156	345	
	A10	6086677	7/11/2000	Umotoy et al.	118	715	
	A11	6032923	3/7/2000	Biegelsen et al.	251	129.01	
	A12	5953634	9/14/1999	Kajita et al.	438	687	
	A13	5500256	3/19/1996	Watabe	427	579	
	A14	5091207	2/25/1992	Tanaka	427	8	
	A15						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	2002-164336	6/7/2002	Japan			yes
	B2						

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Exam. Init.	Ref. Des.	Citation
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	A1	5082517	01-1992	Moslehi	156	345.26	
	A2	6176930	01-2001	Koai et al.	118	715	
	A3	6548112	04-2003	Hillman et al.	427	248.1	11/18/1999
	A4	5911834	06-1999	Fairbairn et al.	134	1.3	
	A5	5876503	03-1999	Roeder et al.	118	715	
	A6	4934401	06-1990	Ikehata et al.	137	82	
	A7						

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